



520.30414R51

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: S. KATO, et al.

RECEIVED

Serial No: 10/066,747

FEB 09 2004

Filed: February 6, 2002

TECHNOLOGY CENTER R3700

Title: VACUUM PROCESSING APPARATUS AND OPERATING
METHOD THEREFOR

Group: 3749

RECEIVED

Examiner: Pamela Anne WILSON

FEB 10 2004

RESPONSE

TECHNOLOGY CENTER R3700

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 3, 2004

Sir:

In response to the Office Action mailed October 3, 2003, Applicants
respectfully submit the following remarks, and also submit the following listed
documents:

- (1) Official Letters Patent for U.S. Patent No. 6,330,755;
- (2) Consent of Assignee, for filing the above-identified reissue
application;
- (3) Statement Under 37 C.F.R. §3.73(b); and
- (4) Supplemental Reissue Application Declaration and Power of
Attorney by Inventor.

Furthermore, noting the comments by the Examiner concerning the
Information Disclosure Statement filed September 23, 2002, also enclosed
herewith is a Supplementing Information Disclosure Statement, with respect